

Title (en)  
Hermetic seal cover and manufacturing method thereof

Title (de)  
Hermetischer Deckel und seine Herstellung

Title (fr)  
Couvercle à fermeture hermétique et son procédé de fabrication

Publication  
**EP 1610380 B1 20100331 (EN)**

Application  
**EP 05253109 A 20050519**

Priority  
JP 2004181968 A 20040621

Abstract (en)  
[origin: EP1610380A2] A hermetic seal cover capable of inhibiting defects such as voids from generating in sealing a package, and a method of manufacturing the seal cover are provided. The hermetic seal cover comprises: a seal cover main body; a Ni plating layer applied onto a surface of the seal cover main body; and a Au-Sn brazing material layer fusion bonded to a surface of the Ni plating layer, and is characterized by a Ni-Sn alloy layer disposed between the Ni plating layer and the Au-Sn brazing material layer. It is preferable if the Ni-Sn alloy layer has a thickness of 0.6-5.0 $\mu$ m. It is also preferable if Au-Sn brazing material layer has a Sn content of 20.65-23.5wt%.

IPC 8 full level  
**H01L 23/04** (2006.01); **H01L 21/50** (2006.01); **H01L 23/10** (2006.01)

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